

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re DIVISIONAL application of)
Koji DAIRIKI)
Based on Serial No. 09/970,908) Group Art Unit: 2824
Filed: October 5, 2001) Examiner: M. Lebentritt
For: SEMICONDUCTOR DEVICE)
MANUFACTURING METHOD, HEAT)
TREATMENT APPARATUS, AND HEAT)
TREATMENT METHOD)

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 09/970,908, and copies of the references can be found in that application.

Respectfully submitted,



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PTO/SB/08A (08-00)

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Complete if Known	
		Application Number	Based on 09/970,908
		Filing Date	October 5, 2001
		First Named Inventor	Koji DAIRIKI
		Group Art Unit	2824
Examiner Name	Michael Lebentritt		
Sheet 1 of 1	Attorney Docket Number	0756-7176	

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
		5,530,265		Takemura	06/25/96	
		5,956,579		Yamazaki et al.	09/21/99	
		6,087,245		Yamazaki et al.	07/11/00	
		6,156,628		Ohnuma et al.	12/05/00	
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		5,739,549		Takemura et al.	04/14/98	
		5,945,711		Takemura et al.	08/31/99	
		5,648,277		Zhang et al.	07/15/97	

FOREIGN PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Office ³	Number ⁴ (if known)			
		JP	07-183540	Ohtani et al.	07/21/95	Abst.

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Tsutsui et al., "Electroluminescence in Organic Thin Films," Photochemical Processes in Organized Molecular Systems, 1991, pp. 437-450.	
		M. A. Baldo et al., "Highly Efficient Phosphorescent Emission from Organic Electroluminescent Devices," Nature Vol. 395, September 10, 1998, pp. 151-154.	
		M. A. Baldo, et al., "Very High-Efficiency Green Organic Light-Emitting Devices Based on Electrophosphorescence," Applied Physics Letters Vol. 75, No. 1, July 5, 1999, pp. 4-6.	
		Tsutsui et al., "High Quantum Efficiency in Organic Light-Emitting Devices with Iridium-Comolex as a Triplet Emissive Center," Japanese Journal of Applied Physics Vol. 38, Part 12B, December 15, 1999, pp. L1502-L1504.	
		U.S. Patent Application Serial No. 10/001,197, including specification and drawings, "Heat Treatment Apparatus and Method of Manufacturing a Semiconductor Device."	

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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